

Electronic Patent Application Fee Transmittal

Application Number:	10576321
Filing Date:	19-Apr-2006
Title of Invention:	PROCESS FOR PRODUCING HIGH-RESISTANCE SILICON WAFERS AND PROCESS FOR PRODUCING EPITAXIAL WAFERS AND SOI WAFERS (AS AMENDED)
First Named Inventor/Applicant Name:	Kazunari Kurita
Filer:	Christopher W. Brody/Melissa Garton
Attorney Docket Number:	12054-0059

Filed as Large Entity

U.S. National Stage under 35 USC 371 Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1510	1510
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Total in USD (\$)				1810